

## Message Text

CONFIDENTIAL

PAGE 01 STATE 180052

55

ORIGIN EB-11

INFO OCT-01 CIAE-00 COME-00 DODE-00 NSAE-00 RSC-01 TRSE-00

EUR-25 AEC-11 ISO-00 /049 R

DRAFTED BY EB/ITP/EWT:LLESE:MAR

9/11/73 EXT 22698

APPROVED BY EB/ITP/EWT:JMGREGORY, JR.

COMMERCE/OEC:RMEYER (SUBS)

RPE

----- 063927

R 111710Z SEP 73

FM SECSTATE WASHDC

TO USMISSION OECD PARIS

INFO AMEMBASSY LONDON

C O N F I D E N T I A L STATE 180052

EXCON

E.O. 11652: GDS-1

TAGS: ESTC, COCOM, PL

SUBJECT: POLAND - SEMICONDUCTOR MANUFACTURING EQUIPMENT

IL 1355

REFS: A. STATE 179259

B. COCOM DOC(73)933

C. OECD PARIS 23636

USDEL REQUESTED ADVISE UKDEL THAT USG WOULD APPRECIATE  
RECEIVING UK VIEWS ON SUBJECT CASE AS QUICKLY AS POSSIBLE  
AFTER RECEIPT OF BROCHURES. RUSH

CONFIDENTIAL

NNN

## Message Attributes

**Automatic Decaptioning:** X  
**Capture Date:** 01 JAN 1994  
**Channel Indicators:** n/a  
**Current Classification:** UNCLASSIFIED  
**Concepts:** EXCEPTIONS LIST, SEMICONDUCTOR DEVICES  
**Control Number:** n/a  
**Copy:** SINGLE  
**Draft Date:** 11 SEP 1973  
**Decaption Date:** 01 JAN 1960  
**Decaption Note:**  
**Disposition Action:** RELEASED  
**Disposition Approved on Date:**  
**Disposition Authority:** morefirh  
**Disposition Case Number:** n/a  
**Disposition Comment:** 25 YEAR REVIEW  
**Disposition Date:** 28 MAY 2004  
**Disposition Event:**  
**Disposition History:** n/a  
**Disposition Reason:**  
**Disposition Remarks:**  
**Document Number:** 1973STATE180052  
**Document Source:** CORE  
**Document Unique ID:** 00  
**Drafter:** LLESE:MAR  
**Enclosure:** n/a  
**Executive Order:** GS RUSH  
**Errors:** N/A  
**Film Number:** n/a  
**From:** STATE  
**Handling Restrictions:** n/a  
**Image Path:**  
**ISecure:** 1  
**Legacy Key:** link1973/newtext/t19730942/aaaabeto.tel  
**Line Count:** 48  
**Locator:** TEXT ON-LINE  
**Office:** ORIGIN EB  
**Original Classification:** CONFIDENTIAL  
**Original Handling Restrictions:** n/a  
**Original Previous Classification:** n/a  
**Original Previous Handling Restrictions:** n/a  
**Page Count:** 1  
**Previous Channel Indicators:**  
**Previous Classification:** CONFIDENTIAL  
**Previous Handling Restrictions:** n/a  
**Reference:** A. STATE 179259  
**Review Action:** RELEASED, APPROVED  
**Review Authority:** morefirh  
**Review Comment:** n/a  
**Review Content Flags:**  
**Review Date:** 23 AUG 2001  
**Review Event:**  
**Review Exemptions:** n/a  
**Review History:** RELEASED <23-Aug-2001 by shawdg>; APPROVED <19-Nov-2001 by morefirh>  
**Review Markings:**

Declassified/Released  
US Department of State  
EO Systematic Review  
30 JUN 2005

**Review Media Identifier:**  
**Review Referrals:** n/a  
**Review Release Date:** n/a  
**Review Release Event:** n/a  
**Review Transfer Date:**  
**Review Withdrawn Fields:** n/a  
**Secure:** OPEN  
**Status:** NATIVE  
**Subject:** POLAND - SEMICONDUCTOR MANUFACTURING EQUIPMENT IL 1355  
**TAGS:** ESTC, US, PL, COCOM  
**To:** OECD PARIS  
**Type:** TE  
**Markings:** Declassified/Released US Department of State EO Systematic Review 30 JUN 2005